

Abstract Submitted
for the MAR08 Meeting of
The American Physical Society

Thermal conductivity reduction by interface roughness in $\text{AlN}_x\text{-GaN}_y$ superlattices. YEE KAN KOH, Univ of Illinois at Urbana-Champaign, YU CAO, Univ of Notre Dame, DAVID CAHILL, Univ of Illinois at Urbana-Champaign, DEBDEEP JENA, Univ of Notre Dame — A reduction of cross-plane thermal conductivity Λ by a factor of two is achieved in $\text{AlN}_{4nm}\text{-GaN}_{52nm}$ superlattices by varying the plasma power during growth. This reduction is attributed to interface roughness, introducing a new parameter to be considered in the design and fabrication of superlattices for thermoelectric applications. Thermal conductivity of $\text{AlN}_x\text{-GaN}_y$ superlattices, $x \sim 4$ nm and $2 < y < 1000$ nm, with rough interfaces is then measured by time-domain thermoreflectance. Λ decreases monotonically as the GaN thickness y decreases, $\Lambda = 6.35 \text{ W m}^{-1} \text{ K}^{-1}$ at $y = 2.2$ nm. We observe no minimum thermal conductivity as a function of period for these rough superlattices. A continuum model incorporating the effects of interface roughness indicates that diffuse scattering is dominant when $y > 20$ nm, and significant coherent transmission occurs when $y < 20$ nm.

David Cahill
Univ of Illinois at Urbana-Champaign

Date submitted: 25 Nov 2007

Electronic form version 1.4